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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10045318	11/09/2001	438	70	1765	Unez-Ercin

APPLICANTS: DeOrnellas Stephen; Jerde Leslie; Cofer Alferd;

CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/692,007 10/19/2000

WHICH IS A CON OF 09/009,369 01/20/1998 PAT 6,287,975

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐	RESCIND ☐	
Foreign priority claimed	☐ yes ☐ no	ATTORNEY DOCKET NO
35 USC 119 conditions met	☐ yes ☐ no	
Verified and Acknowledged Examiners's intials		TEGL-01082US3

TITLE : Method for using a hard mask for critical dimension growth containment

U.S.DEPT. OF COMM./PAT.& TM-PTO-435L(Rev. 12-94)